

Sheet 1 of 1Form PTO-1449  
(REV. 8-83)US Dept. of Commerce  
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109121APPLICATION NO.  
09/819,687

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT  
Eiji NATORIFILING DATE  
March 29, 2001GROUP  
2822

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
MG	5,753,320	5/1998	Mikoshiba et al.		
MG	5,803,974	9/1998	Mikoshiba et al.		
MC	4,668,337	9/1987	Sekine et al.		
MC	5,527,731	6/1996	Yamamoto et al.		

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

MC	Shimizu, Masaru; "Effects of O <sub>3</sub> on Growth and Electrical Properties of Pb(Zr, Ti)O <sub>3</sub> Thin Films by Photoenhanced Metalorganic Chemical Vapor Deposition; Department of Electronics, Kyoto University; September, 1994; pp. 5135-5138.

EXAMINER

*Yana Guerrero*

DATE CONSIDERED

6-30-03

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: March 24, 2003